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DOCKET NO: 211836US2SRD RE

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

;

YASUO OHBA, ET AL.

: EXAMINER: JEROMB JACKSON JR.

SERIAL NO: 09/915,710

:

FILED: JULY 27, 2001

: GROUP ART UNIT: 2815

FOR: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

WRITTEN CONSENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

The assigner of this patent, Kabushiki Kaisha Toshiba, established by assignment of Application Scrial No. 08/400,865, now U.S. 5,656,832, the parent of U.S. 5,929,466, recorded at reel 7444, frame nos. 804-806, consents to the filing of this application for the reissue of U.S. 5,929,466. The undersigned, Taisuke Kato, has the authority to act upon the behalf of the assignee to consent to this reissue.

Taisuke Kato

General Manager, Intellectual Property Division

Date Signed

1:WTT/CE8/211886U8.consent_050564.pog